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Scanning Emitter Lifetime Imaging Microscopy for Spontaneous Emission Control

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We report an experimental technique to map and exploit the local density of optical states of arbitrary planar nanophotonic structures. The method relies on positioning a spontaneous emitter attached to a scanning probe deterministically and reversibly with respect to its photonic environment while measuring its lifetime. We demonstrate the method by imaging the enhancement of the local density of optical states around metal nanowires. By nanopositioning, the decay rate of a pointlike source of fluorescence can be reversibly and repeatedly changed by a factor of 2 by coupling it to the guided plasmonic mode of the wire.

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Spontaneous emission control is at the heart of photonics, the science of engineering the generation, propagation, and absorption of light. Since the pioneering work of Purcell it has been known that the emission properties of a spontaneous emitter can be tailored by its optical environment, which determines the number of final states available for the photon emitted in the transition [1]. While Purcell’s derivation is only valid for certain classes of photonic systems [2], the local density of optical states (LDOS) [1] is always properly defined as the imaginary part of the Green’s function Im{G} [3] and can be thought of as the impedance imposed on a radiating source by its environment [4]. Reaching beyond spontaneous emission, the LDOS is a fundamental quantity that also reflects how the electromagnetic mode structure affects, e.g., thermal emission, radiation by accelerated charges, and forces mediated by vacuum fluctuations [3,5]. The LDOS includes all channels offered by the environment, i.e., radiative decay into the far field, decay into confined photonic or polaritonic resonances, and quenching. Nanophotonic structures exhibiting an LDOS structured at length scales smaller than the wavelength of light include photonic crystals, random scattering materials, and plasmonic structures, all holding promise to achieve control over all aspects of spontaneous emission, including decay rate [6–12], directionality [13,14] and polarization [15].

To unlock the potential of nanophotonics for quantum optics, one requires tools to spatially image the LDOS on a nanometer scale [15,16]. Moreover, to exploit the LDOS to its full potential, it is desirable to first image the LDOS, in order to subsequently position a source deterministically at the optimal location for the actually fabricated structure, as retrieved from the LDOS map. Drop casting of emitters, randomly or on selectively functionalized substrates, is often used to obtain LDOS data [10–13]. However, in this method emitter positions are fixed after deposition and photonic properties have to be deduced from ensemble averages. Therefore, it is difficult to obtain calibrated LDOS values and impossible to first map the LDOS to then controllably place an emitter in the mapped structure. Nanopositioning techniques can assemble photonic devices with single emitters by pushing nano-objects to selected locations [17]. However, such iterative positioning-and-probe sequences are time consuming, and irreversible once the emitter is attached to the structure, limiting the applicability as an LDOS imaging tool. These deficiencies can be overcome by scanning probe techniques. In pioneering experiments, a single emitter fixed in a substrate was used to image the LDOS of a simple plasmonic structure attached to a scanning probe [9,15]. Ground-breaking experiments have been performed also in the converse geometry, where the intensity of emitters attached to sharp probes is monitored while scanning them through the near field of subwavelength structures [18]. Such scanning of pointlike light sources holds great promise for LDOS mapping and nanomechanical manipulation [7], since it is directly compatible with the constraints of planar nanofabrication technologies. Remarkably, even though eagerly anticipated, application of scanning light sources to map LDOS has remained elusive.

In this Letter, we report a nanoscale LDOS imaging technique that combines scanning near field optical microscopy with fluorescence lifetime imaging (FLIM) to map the LDOS around nanoscopic structures by reversible and on-demand positioning of a single nanosized source of fluorescence. As a paradigmatic example, we investigate Au and Ag metal nanowires, structures of significant interest for plasmon quantum optics [10]. We manipulate the decay rate of pointlike sources of fluorescence reversibly and repeatedly by scanning them relative to plasmonic nanowires. At selected source positions a significant fraction of decay events can be funneled into a guided mode, proving the possibility to control nanomechanically both when and where to photons are emitted.
Our scanning emitter lifetime imaging microscope is a homebuilt confocal FLIM system based on an inverted microscope, equipped with a scanning probe that addresses the photonic structure from above [Fig. 1(a)]. As a benchmark experiment, we investigate Ag and Au nanowires deposited on a cleaned glass cover slip. The source of spontaneous emission in our experiments, for brevity termed “the source” in the remainder, is a polystyrene bead with a diameter of 100 nm, infiltrated with approximately $10^3$ randomly oriented dye molecules, a fluorescence peak at 560 nm, and a quantum efficiency close to 1 (Invitrogen Fluospheres F8800). The scanning probe, a pulled glass fiber with an end radius of around 100 nm attached to an xyz piezo arm (piezosystem jena), is held at a constant distance of several nm to the sample surface by shear force feedback [3]. This distance and the size of the fluorescing bead minimize the effect of quenching in our experiment [9]. We dip the probe into a solution of polymethylmethacrylate in anisole and subsequently approach it to a bead (deposited by spin coating on the sample), which we locate by its fluorescence on a CCD camera. The polymer promotes the attachment of a bead to the tip. The light source is pumped by a 532 nm pulsed laser (Time-Bandwidth Products), operating at 10 MHz with a pulse duration $<10$ ps, focused to a diffraction limited spot by a 100× objective (NA 0.95). The fluorescence emitted by the source is collected by the same microscope objective. The fluorescence of the source is collected by the same optics, passes the dichroic beam splitter and an additional long pass filter to be focused onto an avalanche photo diode (APD). The 20 μm active area of the APD (ID-Quantique id100-20 ULN) and 20× magnification between sample and detector result in a confocal arrangement. The APD is connected to a timing card (Becker & Hickl DPC-230), recording the arrival times of the laser pulses and fluorescence photons. Scanning the probe through the laser focus confirms the attachment of the source of fluorescence [Fig. 2(a)] with a well-defined lifetime [Fig. 2(b)].

We now use the probe to map the LDOS of a photonic structure, a template grown Au nanowire [19] with a length of several μm and a diameter of ca. 250 nm [Fig. 1(c)]. We position the probe in the laser focus, as established in Fig. 2(a), such that the source is continuously excited and its fluorescence detected. The sample with the wire is now raster scanned underneath the fixed probe. The acquired arrival times of all photons together with the positioning information allow us to determine the decay dynamics of the source for each position relative to the wire. An excellent fit is obtained to a single exponential decay with a fixed background established from a reference measurement [20]. As the main result of this Letter, Fig. 3(a) shows a spatial map of the lifetime of the source as a function of position with respect to the nanowire. We observe a pronounced reduction in lifetime of the source when it is close to the wire (position confirmed by simultaneously acquired topography, not shown). The black squares in Fig. 3(b) show the first row of Fig. 3(a), with the gray bars illustrating the $3\sigma$ error interval. While the lifetime of the source is around 7 ns when it is far from the wire, it drops rapidly to around 4 ns as soon as the distance between source and wire is of the order of the wire radius. Having moved the wire, the lifetime recovers its original value. The solid circles in Fig. 3(b) take into account all horizontal scan lines in Fig. 3(a). This measurement clearly shows that we can reversibly change the excited state lifetime of the source via its position with respect to the nanowire. The lifetime reported in Fig. 3(a) is inversely proportional to and therefore an unambiguous measure for the LDOS, i.e., Im($G$), at the emission frequency. The ability to image Im($G$) for any planar nanophotonic system is the main result of this Letter. As opposed to position-and-probe techniques [17], our method is a real imaging technique able to repeatedly measure LDOS and calibrate the source.

![FIG. 1 (color online). (a) Schematic of experimental setup. The fluorescent source is attached to a scanning probe and positioned with respect to the structure of interest. A pulsed pump laser is focused onto the source whose fluorescence is collected by the same microscope objective. The fluorescence is split off by a dichroic beam splitter and a color filter and focused onto an APD. (b) Schematic of nanowire with light source in its vicinity. The light source can decay radiatively, nonradiatively, and into surface plasmons. Plasmons may decay via absorption in the wire or radiation from wire end. (c) SEM micrograph of a Au nanowire.](image1)

![FIG. 2 (color online). (a) Fluorescence intensity map of fluorescing probe scanned across unpatterned cover glass. The bright region corresponds to where the probe passes the laser focus. The signal to background ratio exceeds $10^3$ at a pump power of 0.2 μW. (b) Decay trace of photon events from probe positions within box in (a), revealing a single exponential decay with 6.4 ns time constant (straight line through data).](image2)
in situ. In contrast to earlier work, where the LDOS around simple plasmon antennas attached to scanning probes was measured by scanning the antenna with respect to an emitter fixed in a substrate [9], our technique can map the LDOS in any planar photonic system, such as ubiquitous lithographically prepared plasmonic and metamaterial systems.

We proceed to interpret the LDOS measured in the particular structure reported in Fig. 3(a). The doubling of the decay rate is a clear indication of the increased LDOS in the vicinity of the nanowire. The spatial extent of the lifetime reduction is of the order of the wire radius, as was theoretically predicted on the basis that the change in decay rate occurs mostly due to coupling of the emitter to a guided plasmonic mode of the nanowire [21]. This scaling is confirmed by the blue solid line in Fig. 3(b), showing the calculated normalized intensity of the fundamental mode [22]. Surprisingly, the magnitude of the measured LDOS enhancement is comparable to reported values for single NV centers in diamond attached to Ag nanowires [11], despite the much smaller diamond nanocrystal size (50 nm). While physical size clearly limits the positioning accuracy, making the bead physically smaller does not necessarily improve resolution, since the two-level system inside the bead does not get optically closer to the wire if the bead index simultaneously increases (as in diamond). This counterintuitive argument is similar to the argument that the perturbative strength of a near field probe scales with optical size, i.e., polarizability, not simply physical size [7].

Figure 3(c) shows the integrated number of detected photons as a function of probe position from the same scan that yielded Fig. 3(a). Similar fluorescence intensity maps were obtained in earlier experiments with fluorescent scanning probes [18]. The wire in close proximity to the source suppresses its apparent brightness by up to 10 times, while there is a region of enhanced fluorescence on the right-hand side of the wire. The spatial width of these features is of the order of the wire diameter. Such fluorescence intensity data are much more complicated to interpret than lifetime maps as Fig. 3(a) [18,23], since they are a convolution of pump field, collection efficiency, and rate enhancements. The wire causes an enhancement of pump field (polarized perpendicular to the wire axis) on the wire sides and a suppression behind the wire, similar to the case of metallic Mie spheres [2]. We attribute the fluorescence enhancement in Fig. 3(c) to such pump field enhancement. The asymmetry can be explained by an asymmetry in the attachment of the bead to the scanning probe [consecutive rows in Fig. 3(c) are acquired in alternating directions]. Besides pump field suppression, nonradiative channels offered by the wire reduce the observed fluorescence intensity. We argue that the dominant nonradiative decay process in our system is the generation of plasmons, since quenching occurs at emitter-metal distances of only few nanometers [9], much smaller than our source diameter and source-wire separation. While both the observed change in rate and intensity are likely not due to quenching, but rather to excitation of plasmons, a measurement of the LDOS = Im[G] necessarily only reports the sum of all channels.

As an independent, complementary experiment we also studied single-crystalline Ag nanowires. While the plasmonic mode structure of Ag and Au wires is comparable, the exact ratios of decay rates into photons and plasmons will quantitatively differ for different materials [22]. Their more advantageous loss characteristics enable us to both report the LDOS in the vicinity of a Ag wire, and simultaneously obtain a quantitative estimate for the fraction of decay events into plasmons launched on the silver wire. With our scanning probe we position a fluorescing bead on a Ag nanowire with a length of about 2 μm and a diameter of 300 nm (BlueNanoInc, SLV-NW-300). The deposited bead shows up as a faint signature from the scattered intensity in the wire center on a CCD camera under white light illumination [Fig. 4(a)]. In the fluorescence image from the same system under laser wide-field illumination
the fluorescing bead appears as a bright source of emission, while the wire ends are also bright [Fig. 4(b)]. This confirms that the emitters indeed decay into a plasmon that can only couple to free space at irregularities such as the wire ends. A cross section along the wire shows the central peak from the photons emitted into free space and two smaller ones from the wire ends, corresponding to quanta emitted into a plasmon [Fig. 4(c)]. The data [black points in Fig. 4(c)] are fitted well (solid curve through data) with three peaks (curves plotted under envelope). From the areas under the peaks we conclude that the $\beta$ factor, i.e., the fraction of quanta emitted into the wire mode, is around 20% where we have neglected plasmon loss en route to the wire ends. We also measured the decay of the source on the probe away from the wire [blue squares in Fig. 4(d)] and after deposition on Ag nanowire (green diamonds). Red lines are biexponential fits.

In conclusion, we presented a technique to map $\text{Im}\{G\}$ of arbitrary photonic structures with nanometer resolution. Such scanning emitter lifetime imaging is suited to exploit the backaction of the photonic environment on a spontaneous emitter for a plethora of structures of current interest, hitherto inaccessible to established near and far field techniques. Our work shows repeated switching of the decay rate of a pointlike light source by a factor of 2 by reversible and on-demand positioning of an emitter within its nanoscale photonic environment. This constitutes a major step towards full nanomechanical control over all aspects of spontaneous emission, including decay rate, directionality, and spectral composition. In the current race towards scanning just a single quantum system [18], our method will even give access to the reverse process of spontaneous emission, i.e., the absorption of single photons in the vicinity of nanostructures [24], as well as position dependent coupling, energy transfer, and photon-photon correlations between emitters linked by a nanophotonic structure [25].

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